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PATENT  
Customer No. 23494  
Attorney Docket No. T1-31133

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Antonio L. P. Rotondaro

Application No.: 10/001,483

Group Art Unit: 2823

Examiner: Michelle Estrada

Filed: November 1, 2001

For: METHOD TO IMPROVE THE  
UNIFORMITY AND REDUCE THE  
SURFACE ROUGHNESS OF THE  
SILICON DIELECTRIC  
INTERFACE

Assistant Commissioner for Patents  
Washington, DC 20231

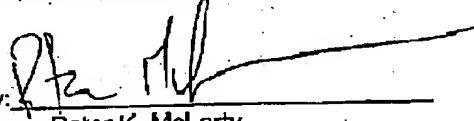
Sir:

POWER OF ATTORNEY

Please grant Jonathan A. Hack, Reg. No. 47,623, power of attorney and allow  
him to be an attorney of record for the above referenced application.

Respectfully submitted,

Dated: May 11, 2004

By:   
Peter K. McLarty  
Reg. No. 44,923

TOTAL P.02

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**To:** Examiner M. Estrada**From:** Jonathan A. Hack

Art Unit 2823

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**Fax:** 703.872.9306**Pages:** 2**Phone:** 572.272.1858**Date:** May 11, 2004**Re:** U.S. Application No.: 10/001,483**CC:**

Attorney Docket No.: TI-31133

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